

FORM PTO-1449 (MODIFIED)  LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT	ATTORNEY DOCKET NO. SP01-301	SERIAL NO. To Be Assigned
APPLICANT Sabia		
FILING DATE: Herewith		GROUP: To Be Assigned

10/035564  
 10/26/01  
 10/035564

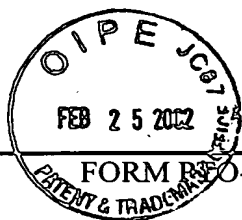
REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
<i>JHR</i> ↓ V	AA	5,915,193	6/22/99	Tong et al.	438	455	
	AB	5,785,874	7/28/98	Eda	216	24	
	AC	5,932,048	8/3/99	Furukawa et al.	156	153	
	AD	6,129,854	10/10/00	Ramsey et al.	216	18	
	AE	6,153,495	11/28/00	Kub et al.	438	459	
	AK						

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
	AL						
	AM						
	AN						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)		
<i>JHR</i> ↓ V	AO	A. Sayah, D. Solignac, T. Cueni, "Development of novel low temperature bonding technologies for microchip chemical analysis applications," Sensors and Actuators, 84 (2000) pp. 103-108.
	AP	P. Rangsten, O. Vallin, K. Hermansson, Y. Backlund, "Quartz-to-Quartz Direct bonding," J. Electrochemical Society, V. 146, N. 3, pp. 1104-1105, 1999).
	AQ	H. Nakanishi, T. Nishimoto, M. Kani, T. Saitoh, R. Nakamura, T. Yoshida, S. Shoji, "Condition Optimization, Reliability Evaluation of SiO <sub>2</sub> -SiO <sub>2</sub> HF Bonding and Its Application for UV Detection Micro Flow Cell," Sensors and Actuators, V. 83, pp. 136-141, 2000.
	AR	A. Yamada, et al., Bonding Silicon wafer to Silicon Nitride With Spin-on Glass Adhesive, Electronics Letters, March 26, 1987, Vol. 23, No. 7.
	AS	D.J. Harrison, et al., Micromachining a Miniaturized Capillary Electrophoresis-Based Chemical Analysis System on a Chip, Science 261 (1993) 895-897.
	AT	W.P. Maszara, Silicon-on-insulator by Wafer Bonding: A Review, J. Electrochemical Society 138 (1991) 341-347.
	AU	D-W. Shin, et al., The Stacking Faults and Their Strain Effect at the Si/SiO <sub>2</sub> Interfaces of a Directly Bonded SOI (silicon on insulator), Thin Solid Films, V. 346, pp. 169-173, 1999.
	AV	Q-Y. Tong, et al., The Role of Surface Chemistry in Bonding of Standary Silicon Wafers, J. Electrochemical Society V. 144, N. 1, pp. 384-389, 1997

EXAMINER: <i>Jenna Rossi</i>	DATE CONSIDERED: <i>7/25/03</i>
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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FORM PTO-1449 (MODIFIED)  
LIST OF PATENTS AND  
PUBLICATIONS  
FOR APPLICANTS INFORMATION  
DISCLOSURE STATEMENT

ATTORNEY DOCKET NO.

SP01-301

SERIAL NO.

10/035,564

APPLICANT Sabia et al.

FILING DATE October 26, 2001

GROUP: To Be  
Assigned

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA						
	AB						
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FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes	No
<i>JEL</i>	AL	52[1977]-78450	7/1/77	Japan	G02B	5/14	X	
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

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DATE CONSIDERED:

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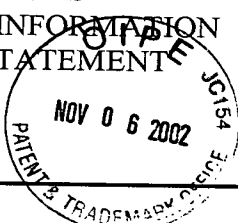
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DISCLOSURE STATEMENT

SP01-301

10/06/2001

APPLICANT Sabia et al.

FILING DATE October 26, 2001

GROUP: To Be  
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## REFERENCE DESIGNATION

## U.S. PATENT DOCUMENTS

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## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub- Class	Translation Yes No
JLR	AL	P2000-56225A	2/25/00	Japan	G02B	27/28	X
	AM						
	AN						
	AO						
	AP						
	AQ						

## OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

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EXAMINER:

*Jessica Rossi*

DATE CONSIDERED:

*7/28/03*

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LIST OF PATENTS AND  
PUBLICATIONS

SP01-301

10/035564

FOR APPLICANTS INFORMATION  
DISCLOSURE STATEMENT

APPLICANT SABIA ROBERT, et al.

FILING DATE 10/26/2001

GROUP: 2812

## REFERENCE DESIGNATION

## U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date if Approp.
<i>Jfl</i>	AA	5,183,710	2/2/93	Gerbino			
	AB	5,451,547	9/19/95	Himi et al			
	AC						
	AD						
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	AH						
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## FOREIGN PATENT DOCUMENTS

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	AL						
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